

Notice of References Cited			Application/Control No.	Applicant(s)/Patent Under Reexamination	
			09/838,513	CHEN ET AL.	
Examiner			Art Unit	2823	Page 1 of 1
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U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-5,937,325	08-1999	Ishida, Emi	438/655
*	B US-6,514,859 B1	02-2003	Erhardt et al.	438/664
C	US-			
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E	US-			
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G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages
*	U Mouroux, Allette; The Reactive Formation of TiSi ₂ in the Presence of Refractory Metals (from V to W), Royal Institute of Technology, Department of Electronics, Stockholm 1,999.
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^{*}A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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